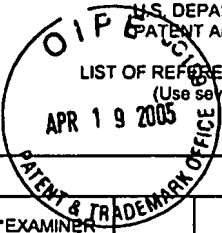


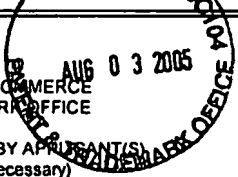
FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. 03500.017972		APPLICATION NO. 10/807,103	
				APPLICANT KOICHI MATSUDA ET AL.			
				FILING DATE March 24, 2004		GROUP 1709	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		5,021,100	06/04/91	Ishihara et al.	136	249	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
JS	JP	2001-308354	11/02/01	Japan			Abstract
JS	JP	2-237172	09/19/90	Japan			Abstract
JS	JP	63-77167	04/07/88	Japan			No
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
JS		Yamamoto, Kenji, "Thin-film polycrystalline Silicon Solar Cell", Applied Physics, The Japanese Society of Applied Physics, May 2002, Vol. 74 No. 5, pp. 524-527.					
EXAMINER				/Jackson Smith/			
DATE CONSIDERED				04/18/2007			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

Form #62

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				APPLICANT KOICHI MATSUDA ET AL.			
				FILING DATE March 24, 2004		GROUP 1709	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
JS		K. Yamamoto, "Thin-film Polycrystalline Silicon Solar Cell", Applied Physics, The Japan Society of Applied Physics, May, 2002, vol. 71, No. 5, pgs. 522-527 (English translation)					
JS		K. Yamamoto, "Thin-film Polycrystalline Silicon Solar Cell", Applied Physics, The Japan Society of Applied Physics, May, 2002, vol. 71, No. 5, pgs. 522-527 (with handwritten English translation of text shown in drawings)					
EXAMINER /Jackson Smith/				DATE CONSIDERED 04/18/2007			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)	ATTY DOCKET NO.	APPLICATION NO.
	03500.017972	10/807,103
	APPLICANT KOICHI MATSUDA ET AL.	
	FILING DATE	GROUP
	March 24, 2004	1709

U.S. PATENT DOCUMENTS



*EXAMINER		DOCUMENT					FILING DATE
JS		6,180,870 B1	01/30/01	Sano et al.	136	258	
JS		4,612,411	09/16/86	Wieting et al.	136	265	
JS		6,426,547 B1	07/30/02	Greenberg et al.	257	656	

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
JS	CN	1175095A	03/04/98	China			Abstract U.S. 6,180,870 B1

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)	
EXAMINER	/Jackson Smith/
DATE CONSIDERED	04/25/2007